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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812

Examiner: Jennifer M. Kennedy

In Re PATENT APPLICATION of:

Applicant(s): Osamu KATO)

Serial No.: 10/689,032)

Filing Date: October 21, 2003)

For: METHOD FOR FABRICATING A GATE)
MASK OF A SEMICONDUCTOR)
DEVICE)

Docket No.: FUJI 138)

**RESPONSE TO
ELECTION OF SPECIES
REQUIREMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Election of Species Requirement dated February 15, 2005, Applicant elects the embodiment of species I, as shown in Figures 1A through 1D, for examination. Claims 1, 2, 5, and 6 read on the elected species. The election is made without traverse. By making this election and selecting these claims for examination, however, Applicant does not restrict the scope of the listed claims to only the features of the exemplary embodiment shown in Figs. 1A through 1D. Rather, these claims may also read, for example, on other exemplary embodiments described in the specification, and should be afforded the broadest scope allowed by the relevant prior art.

Examination of the application on the merits is respectfully requested.

Respectfully submitted,

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March 9, 2005
Date

RHB:vm

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